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Nanocomposites SnO₂/SiO₂:SiO₂ Impact on the Active Centers and Conductivity Mechanism

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Abstract: This paper is focused on the effect of the stabilizing component SiO₂ on the type and concentration of active sites in SnO₂/SiO₂ nanocomposites compared with nanocrystalline SnO₂. Previously, we found that SnO₂/SiO₂ nanocomposites show better sensor characteristics in CO detection (lower detection limit, higher sensor response, and shorter response time) compared to pure SnO₂ in humid air conditions. Nanocomposites SnO₂/SiO₂ synthesized using the hydrothermal method were characterized by low temperature nitrogen adsorption, XRD, energy dispersive X-ray spectroscopy (EDX), thermo-programmed reduction with hydrogen (TPR-H₂), IR-, and electron-paramagnetic resonance (EPR)-spectroscopy methods. The electrophysical properties of SnO₂ and SnO₂/SiO₂ nanocomposites were studied depending on the oxygen partial pressure in the temperature range of 200–400 °C. The introduction of SiO₂ results in an increase in the concentration of paramagnetic centers Sn³⁺ and the amount of surface hydroxyl groups and chemisorbed oxygen and leads to a decrease in the negative charge on chemisorbed oxygen species. The temperature dependences of the conductivity of SnO₂ and SnO₂/SiO₂ nanocomposites are linearized in Mott coordinates, which may indicate the contribution of the hopping mechanism with a variable hopping distance over local states.

Keywords: nanocomposites; tin dioxide; silicon dioxide; oxygen chemisorption; active surface groups; paramagnetic centers; conductivity mechanism

1. Introduction

The development of high-temperature sensors necessary for local monitoring of the concentration of toxic compounds in exhaust (flue) gases and atmospheric emissions requires the creation of new materials to be stable at high temperatures of 300–600 °C. These specific tasks imply a high ambient temperature, which determines the requirements primarily for the stability of materials. This distinguishes high-temperature sensors from other types of semiconductor sensors operating, for example, at room temperature [1–3]. The grain growth under a high temperature results in an increase in the area of contact between the crystallites and the formation of necks between the grains. This, in turn, determines the structure and properties of the conducting cluster responsible for the transport of charge carriers. Tin dioxide SnO₂ is a wide-gap *n*-type semiconductor (E_g = 3.6 eV at 300 K) that has the most widespread technological application as a material for semiconductor gas sensors [4]. In

addition to the indicated above low stability of sensor characteristics during long-term functioning at high temperatures, the main disadvantages of the SnO₂-based sensors are low selectivity and reduced sensitivity in humid air [5]. The increase in the sensitivity and selectivity of nanocrystalline SnO₂-based materials can be achieved by chemical modification of the surface of tin dioxide [6,7], as well as by using the dynamic temperature mode followed by mathematical processing of the sensor response [8]. However, these approaches also impose additional requirements on the stability of the microstructure of the sensitive material.

One of the possible ways to solve the problem of low stability of the microstructure at high temperatures is to create nanocomposites based on semiconductor oxides and the stabilizing component, for example amorphous silicon oxide SiO₂. It was shown that the addition of SiO₂ allows obtaining composite materials with high specific surface area which demonstrate stable microstructure characteristics during high-temperature annealing [9–16]. An increase in the sensor signal to volatile organic compounds (VOCs) and CO was observed [9–16]. Tricoli et al. demonstrated [9,10] that in SnO₂/SiO₂ nanocomposites obtained by direct-flame aerosol deposition, the doping with SiO₂ prevents SnO₂ grain and crystal growth, most likely due to formation of interstitial solid solution of Si in the SnO₂ lattice. It was concluded that SnO₂/SiO₂ nanocomposites can enhance the long-term stability and VOC sensitivity of SnO₂-based gas sensors while having minimal impact on the residual SnO₂ properties [10]. The SiO₂@SnO₂ core-shell nanofibers, composed of amorphous SiO₂ fiber core, and the outer layer, formed by uniform SnO₂ particles, were investigated as gas sensors to ethanol, ammonia, benzene, toluene, chloroform, and hexane gases, but exhibited an enhanced gas response to ethanol with a short response time [11]. Similarly, the effects of surface chemical modification with SiO₂ (using wet-chemical modification through the dehydration-condensation reaction) on the thermal stability and CO gas-sensing properties of SnO₂ were investigated by Zhan et al. [12]. It was shown that the presence of SiO₂ on the tin dioxide surface effectively inhibits the growth of SnO₂ nanocrystals. The sensitivity enhancement in CO detection was ascribed to the ultrafine crystal size, which is less than twice the Debye length. A similar explanation for the increase in sensor sensitivity of SnO₂-decorated SiO₂ samples to acetone and ethanol was proposed by Asgari et al. [13]. Information about sensor properties of SnO₂/SiO₂ nanocomposites is presented in Table 1.

Table 1. Characteristics and gas sensor properties of SnO₂/SiO₂ nanocrystalline materials.

Material Type	Synthesis Method	$\frac{[Si]}{[Si]+[Sn]}$ mol.%	Gas	C _{gas} , ppm	T _{mes} , °C	Sensor Signal	Reference
Thick film	Direct flame spray pyrolysis	7.8	Ethanol	50	320	318	[9]
Core-shell nanofibers	Single-spinneret electrospinning	75	Ethanol	200	not defined	37	[11]
Powders	Wet-chemical modification through the dehydration-condensation reaction	4.8	CO	100	260	350	[12]
Powders	Micro-emulsion followed by ultrasonic-assisted deposition-precipitation method	33	Ethanol Acetone	300 300	270 270	1066 2193	[13]
Thin film	Sol-gel method and electron-beam irradiation treatment	20	Acetone Isopropanol	1000	300	27 16	[14]
Core-shell nanofibers	Template synthesis	not defined	H ₂ CO	200 200	450 400	500 100	[15]

At the same time, the addition of SiO₂ affects not only the microstructure of the SnO₂ semiconductor matrix, but also the composition of surface-active groups, which alters the reactivity of the obtained materials in the interaction with the gas phase. However, the detailed studies of the effect of SiO₂ on the surface composition and reactivity of SnO₂ in the solid-gas interactions are very few. Nalimova et al. [14]

demonstrated that the electron beam processing of the sol-gel SnO₂-SiO₂ thin films leads to a significant increase in their sensitivity towards acetone and isopropanol vapors. It is found that the observed effect is correlated with an increase in the concentration of the Brønsted acid sites. Gunji et al. [15] studied the gas sensing properties of template synthesized SiO₂/SnO₂ core-shell nanofibers towards H₂ and CO in dry and humid conditions in comparison with SnO₂ nanoparticles produced by a hydrothermal method. The SiO₂/SnO₂ nanofibers showed a prominent sensor response in humid atmosphere. It was supposed that SiO₂ particles acted as a water absorber to hinder hydroxyl poisoning of adjacent SnO₂.

In our previous work [16], the sensor properties of SnO₂/SiO₂ nanocomposites obtained by the hydrothermal route were investigated during CO detection in dry and humid (relative humidity RH = 4–65%) air in the temperature range 150–400 °C. It was found that SnO₂/SiO₂ nanocomposites show better sensor characteristics in CO detection (lower detection limit, higher sensor response, and shorter response time) compared to pure SnO₂ in humid air conditions. Moreover, the resistance of SnO₂/SiO₂ nanocomposites was less sensitive to the RH change over the whole range of operating temperatures. The obtained sensor parameters of nanocrystalline SnO₂ and SnO₂/SiO₂ nanocomposites [16] are summarized in Table 2.

Table 2. Sensor properties of nanocrystalline SnO₂ and SnO₂/SiO₂ nanocomposites in CO detection [16].

Sample	$\frac{[Si]}{[Si]+[Sn]}$ mol.%(^a)	R (400 °C), Ω(^b)	LDL, ppm(^c)		τ_{res}^{90} , min(^d)		τ_{rec}^{90} , min(^e)	
			RH = 1%	RH = 20%	RH = 1%	RH = 20%	RH = 1%	RH = 20%
SnO ₂	0	7.3×10^7	1.5	9.0	3.6 ± 0.2	5.2 ± 0.6	6.4 ± 0.3	5.8 ± 0.7
SnSi13	13	3.2×10^8	4.3	7.0	2.7 ± 0.1	2.6 ± 0.1	7.2 ± 0.1	7.0 ± 0.7
SnSi19	19	2.2×10^9	3.3	7.8	2.6 ± 0.1	2.9 ± 0.1	7.9 ± 0.4	6.8 ± 0.8

(^a)determined by energy dispersive X-ray spectroscopy (EDX); (^b)resistance in dry air at 350 °C; (^c)CO low detection limit; (^d)90% response time at the temperature of maximum sensor signal (100 ppm CO); (^e)90% recovery time at the temperature of maximum sensor signal (100 ppm CO).

This paper analyzes the effect of the stabilizing component SiO₂ and the appearance of the SnO₂/SiO₂ interface on the type and concentration of active sites in SnO₂/SiO₂ nanocomposites compared with nanocrystalline SnO₂. The focus is on the predominant forms of chemisorbed oxygen and paramagnetic centers and their relationship with the mechanism of charge carrier transport in these materials.

2. Materials and Methods

2.1. Materials Synthesis

Semiconductor materials based on SnO₂/SiO₂ were obtained by hydrothermal processing of a xerogel SnO₂ · xH₂O and an alcohol solution of Si(OH)₄. SnCl₄·5H₂O (98%, Sigma-Aldrich, Saint Louis, MO, USA) and tetraethoxysilane (TEOS) (98%, Sigma-Aldrich) were used as Sn⁴⁺ and Si⁴⁺ precursors, respectively. The synthesis process is described in detail in our previous work [16]. In brief, SnO₂·xH₂O xerogel was obtained by hydrolysis of 3M SnCl₄·5H₂O aqueous solution with 25% NH₃·H₂O aqueous solution, followed by drying at 50 °C. Si(OH)₄ alcohol solution was produced through TEOS hydrolysis in a reaction medium consisting of 90% ethyl alcohol, 5% water, and 5% TEOS (by volume) at pH = 4. To obtain the SnO₂/SiO₂ composites, the SnO₂·xH₂O xerogel and Si(OH)₄ alcohol solution were autoclaved at 150 °C for 24 h with a constant stirring. The reaction product was repeatedly washed with ethyl alcohol and water, dried at room temperature, and annealed at 600 °C for 24 h. The annealing temperature was selected based on the thermal analysis with mass spectral determination of CO₂ (*m/z* = 44). According to the obtained data, all possible organic by-products of the TEOS hydrolysis decomposed at a temperature of 500–550 °C [16]. The designations of samples and their characteristics are given in Table 3.

Table 3. Composition and microstructure parameters of the SnO₂ and SnO₂/SiO₂ nanocomposites.

Sample	$\frac{[Si]}{[Si]+[Sn]}$ mol. % ^(a)	$d_{XRD}(\text{SnO}_2)$, nm ^(b)	$S_{BET} \pm 5$ m ² /g ^(c)
SnO ₂	0	11 ± 1	23
SnSi13	13	7 ± 1	99
SnSi19	19	6 ± 1	156
SiO ₂	100	-	327

^(a) determined by EDX; ^(b) estimated using the Scherer formula; ^(c) determined by low-temperature N₂ adsorption.

2.2. Materials Characterization

The composition of the samples was investigated by energy dispersive X-ray spectroscopy (EDX) using a Zeiss NVision 40 (Carl Zeiss, Oberkochen, Germany) scanning electron microscope equipped with a X-Max detector (Oxford Instruments, Abington, UK) operated at 20 kV.

The phase composition was determined by X-ray diffraction on a DRON-4 diffractometer (SPE "Burevestnik", Saint-Petersburg, Russia) using monochromatic CuK α radiation ($\lambda = 1.5406 \text{ \AA}$). The survey was carried out in the range of $2\theta = 10\text{--}60^\circ$ with a step of 0.1° . The crystallite size d_{XRD} of the SnO₂ phase was estimated from the broadening of the (110) and (101) reflections using the Scherer formula. Specific surface area S_{BET} was determined by low-temperature nitrogen adsorption on Chemisorb 2750 (Micromeritics, Norcross, GA, USA) with subsequent analysis using the BET model (single point).

The microstructure of the SnO₂/SiO₂ nanocomposites was studied by high-resolution transmission electron microscopy (HRTEM) on a JEM 2010 (JEOL, Tokyo, Japan) instrument with an accelerating voltage of 200 kV and a lattice resolution of 0.14 nm. The images were recorded using a CCD matrix of the Soft Imaging System (Mega View III, Münster, Germany).

The surface composition (including hydroxyl groups, adsorbed water, and paramagnetic centers) was studied using Fourier transformed infrared spectroscopy (FTIR), thermal analysis, and electron-paramagnetic resonance (EPR) spectroscopy. The IR spectra were recorded on a Frontier FTIR spectrometer (Perkin Elmer Inc., Waltham, MA, USA) in the transmission mode in the range of $4000\text{--}400 \text{ cm}^{-1}$ with 1 cm^{-1} step. The powders (1 wt%) were grinded with dried KBr (Aldrich, "for FTIR analysis") and pressed into tablets. Thermal analysis of the samples was carried out on a STA 409 HC Luxx thermal analyzer (Netzsch-Gerätebau GmbH, Selb, Germany). The samples were heated in 30 mL/min air flow with a rate of $10^\circ\text{C}/\text{min}$. Mass spectral analysis of gaseous products released during the heating was performed using a QMS 403 C Aëolos quadrupole mass spectrometer (Netzsch, Germany). The study of paramagnetic centers was performed on a Bruker ELEXSYS-580 EPR spectrometer (Billerica, MA, USA) with a working frequency of 9.5 Hz and a sensitivity of 5×10^{10} spin/Gs. The g -values were determined based on Mn⁺⁺ standard.

The oxidative surface-active sites were studied by the method of thermo-programmed reduction with hydrogen (TPR-H₂) on the Chemisorb 2750 (Micromeritics, Norcross, GA, USA). The pre-treatment of the samples before the measurements was carried out in oxygen flow (20 mL/min) and included heating ($10^\circ\text{C}/\text{min}$) to 200°C , annealing at 200°C for 30 min, and cooling down to room temperature. During the TPR-H₂ experiment, a H₂/Ar gas mixture (8 vol.% H₂) was passed through a flow-through quartz test tube with a sample. Heating ($10^\circ\text{C}/\text{min}$) was carried out to 900°C (in the case of the SnSi19 sample to 1000°C).

For electrophysical measurements, the powders of SnO₂ and SnO₂/SiO₂ nanocomposites were mixed with α -terpineol (90%, Merck, Darmstadt, Germany) to form a paste and then deposited on alumina substrates with platinum contacts on the top side and a platinum heater on the back side. Thick films thus obtained were dried at 50°C for 24 h and annealed at 300°C using the back side heater (Figure 1). The registration of sample resistance was carried out automatically in the voltage stabilized DC mode with applied voltage of 1.3 V. The interaction of nanocomposites with oxygen was

investigated *in situ* by measuring the conductivity of sensors depending on the oxygen partial pressure in the gas phase. To create gas mixtures with a pre-assigned oxygen content the commercially available Ar (no more than 0.002 vol. % O₂) and synthetic air (20 vol. % O₂) were used. In all experiments, the gas mixture flow was maintained constant at 100 ± 0.5 mL/min. Gas mixtures with fixed oxygen concentrations (0.002, 2, 5, 10, 15, and 20 vol.%) were prepared by mixing synthetic air and Ar using electronic gas flow controllers (Bronkhorst, Ruurlo, Netherlands). The measurements were carried out in the temperature range of 400–200°C. Between the temperature changes, the sensors were kept in Ar flow for 40 min.

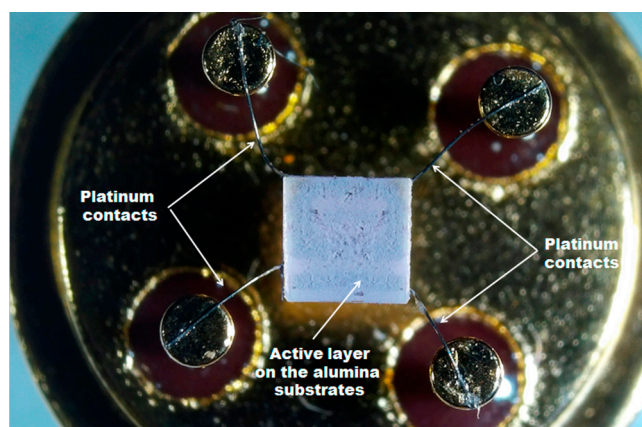


Figure 1. Active layer of SnO₂/SiO₂ nanocomposite on Al₂O₃ substrate fixed to the chip holder.

3. Results and Discussion

Energy dispersive X-ray spectroscopy (EDX) analysis of nanocomposites showed that their composition corresponds to that specified during synthesis (Table 3) [16]. X-ray diffraction revealed that SnO₂ (cassiterite, ICDD 41-1445) is the only crystalline phase in all samples. Silicon oxide obtained under similar hydrothermal conditions in the absence of SnO₂·xH₂O xerogel is X-ray amorphous (Figure 2a). As evidenced by the increase in the width of SnO₂ reflections (Figure 2b), the increase in silicon content in the nanocomposites leads to the decrease in the size of SnO₂ crystallites under conditions of identical isothermal annealing. According to the low-temperature nitrogen adsorption data, the addition of SiO₂ prevents sintering of tin dioxide particles during high-temperature annealing and allows obtaining samples with high specific surface area (Table 3).

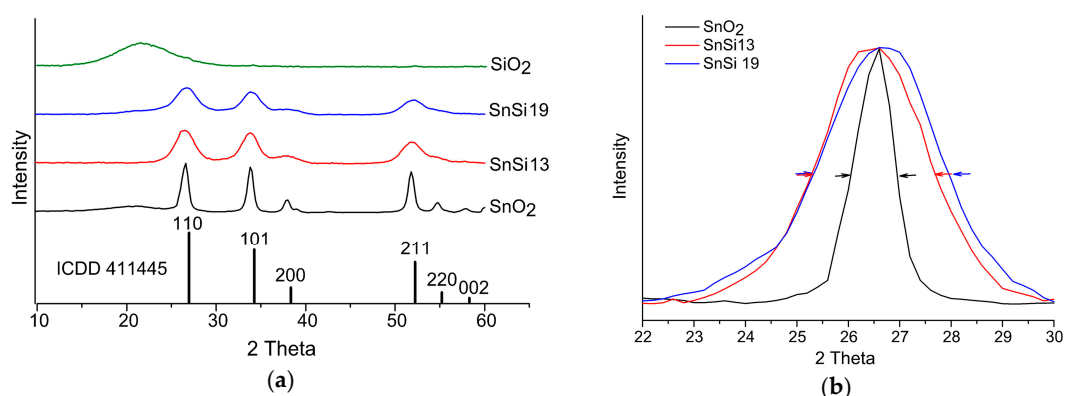


Figure 2. (a) Diffractograms of nanocrystalline SnO₂, SiO₂, and SnO₂/SiO₂ nanocomposites. (b) Normalized (110) diffraction peak of SnO₂ phase in SnO₂ and SnO₂/SiO₂ nanocomposites.

By HRTEM, it was found [16] that nanocrystalline SnO₂ is formed by large crystalline nanoparticles, while SiO₂ is completely amorphous. On the images of SnSi13 (Figure 3a) and SnSi19 (Figure 3b)

samples, crystalline SnO₂ particles (8–12 nm) and amorphous SiO₂ particles (5–15 nm) that are distributed over the surface of the semiconductor oxide can be distinguished.

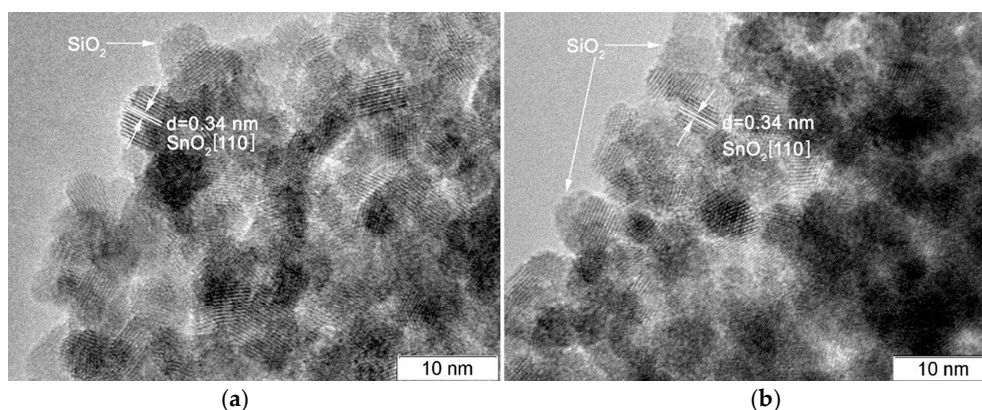


Figure 3. Images of: (a) SnSi 13; (b) SnSi 19 samples.

Using IR spectroscopy, it was studied how the addition of silicon dioxide affects the type and concentration of active groups on the SnO₂ surface. The normalization of the IR spectra of composite samples to the intensity of Sn–O–Sn oscillations (670 cm⁻¹) showed an increase in the concentration of hydroxyl groups on the surface of the samples with the growth of SiO₂ content (Figure 4). In the range of 700–400 cm⁻¹, the spectra of SnSi 13 and SnSi 19 contain the peaks corresponding to all the vibrations of individual SnO₂ and SiO₂. The detailed assignment [17–19] of the oscillations in IR spectra of nanocomposites is presented in Table 4.

The observed trend to increase the number of hydroxyl groups on the surface of composite samples is in agreement with the results of the analysis of the amount of water desorbed from the surface of SnO₂, SnSi 13, SnSi 19, and SiO₂ samples. The study was carried out by thermogravimetric (TG) analysis, before which the samples were kept in a desiccator at RH ≈ 100% for two days. Based on the data obtained, it can be concluded that more water is desorbed from the surface of nanocomposites than from pure SnO₂ and SiO₂ (Figure 5, Table 5). Since this increase in adsorption capacity is characteristic of SnO₂/SiO₂ nanocomposites, it can be assumed that adsorption sites for water molecules are formed on the SnO₂/SiO₂ interface.

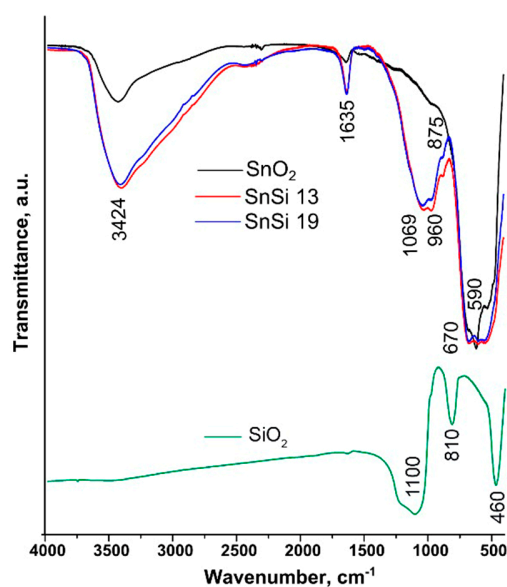
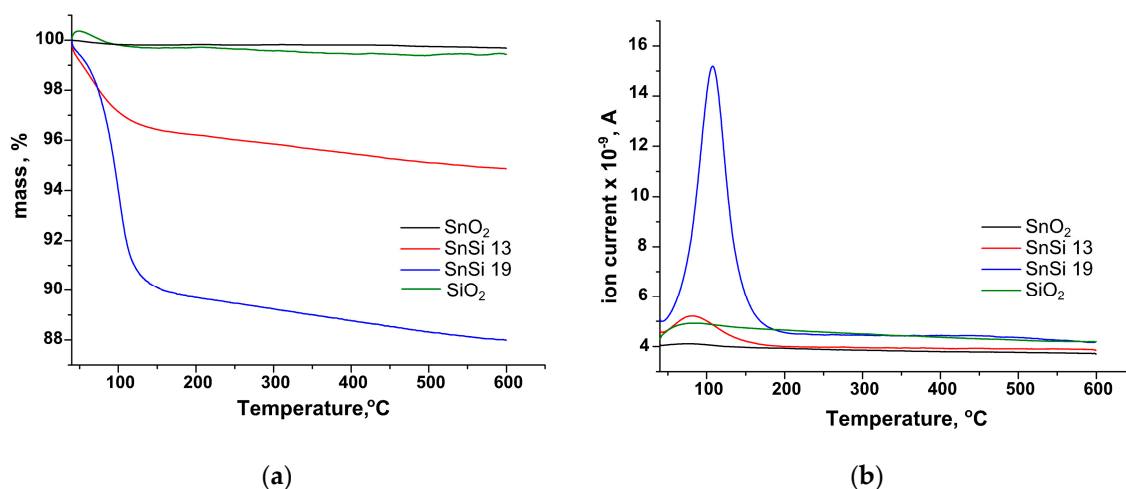


Figure 4. The IR spectra of the SnO₂, SnSi13, SnSi19, and SiO₂.

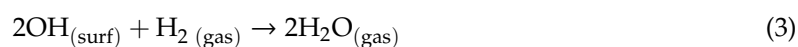
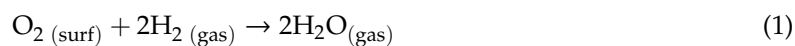
Table 4. Assignment of the oscillations present in the IR spectra of SnO₂, SnSi 13, SnSi 19, and SiO₂.

Wavenumber, cm ⁻¹	Oscillation	Ref.
3650–2500	$\nu(\text{O-H})$	[17]
1635	$\delta(\text{H}_2\text{O})$	[17]
1250–870	$\nu_{\text{ass}}(\text{Si-O-Si}), \nu(\text{Si-OH})$	[18]
960	$\nu_{\text{ass}}(\text{O}_3\text{Si-Sn})$	[19]
810	$\nu_{\text{sim}}(\text{Si-O-Si})$	[18]
670	$\nu_{\text{ass}}(\text{Sn-O-Sn})$	[18]
590	$\nu(\text{Sn-OH})$	[17]
530	$\nu_{\text{sim}}(\text{Sn-O})$	[17]
460	$\delta(\text{Si-O})$	[18]

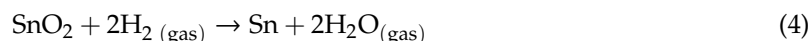
**Figure 5.** (a) TG curves; (b) temperature dependences of the H₂O ion current ($m/z = 18$) for SnO₂, SnSi 13, SnSi 19, and SiO₂, kept in a desiccator at RH \approx 100% for two days.**Table 5.** Estimation of the amount of desorbed water according to the results of thermal analysis.

Sample	Amount of Desorbed Water, mol/m ²
SnO ₂	4.9×10^{-6}
SnSi13	1.9×10^{-5}
SnSi19	3.4×10^{-5}
SiO ₂	5.3×10^{-7}

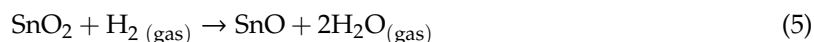
The concentration of surface oxygen containing species was estimated by the method of thermo-programmed reduction with hydrogen (TPR-H₂). Figure 6 shows the temperature dependences of hydrogen consumption during the reduction of SnO₂, SnSi 13, SnSi 19, and SiO₂. In the experimental conditions, the reduction of pure silicon dioxide doesn't occur. For SnO₂ and SnO₂/SiO₂ nanocomposites, several regions can be distinguished in TPR profiles. The first peak is in the range of 200–300 °C, which corresponds to the reduction of chemisorbed oxygen (O₂⁻, O⁻, O²⁻) and surface OH⁻ groups:



On the SnO₂ TPR profile, a peak with a maximum at 621 °C corresponds to the reduction of SnO₂ to metallic tin:



In the case of composite samples, two peaks appear in this temperature region. The appearance of a signal with a maximum in the region of 520 °C is possibly due to the partial reduction of $\text{Sn}^{4+} \rightarrow \text{Sn}^{2+}$ [19,20]:



The peak corresponding to the $\text{Sn}^{4+} \rightarrow \text{Sn}^0$ reduction for the SnSi 19 sample is shifted toward higher temperatures with a maximum of 701 °C. This may be due to the difficult reduction of tin atoms linked with SiO_4 groups.

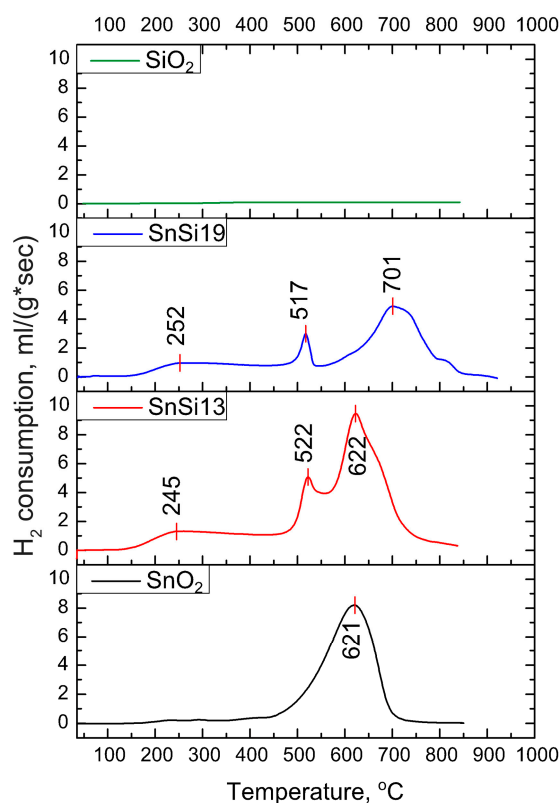


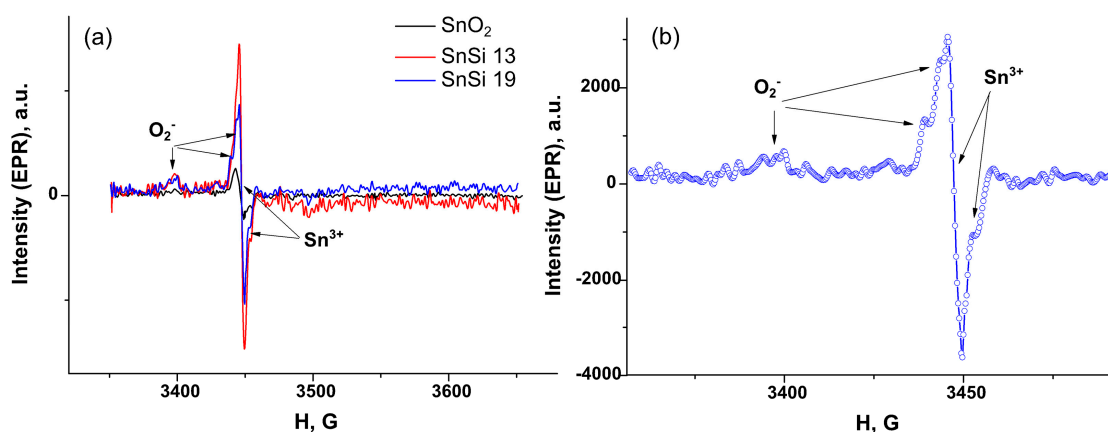
Figure 6. Profiles SnO_2 , SnSi 13, SnSi 19, and SiO_2 .

The results of the TPR- H_2 experiments are summarized in Table 6. During the measurements, the signal from the thermal conductivity detector (TCD, arb. units), which is proportional to the rate of hydrogen consumption, was registered depending on the temperature inside the reactor. The quantity of hydrogen consumed in a given temperature range (25–400 °C or 400–900 °C) was calculated using calibration curves obtained for a reference Ag_2O sample. The total quantity of hydrogen consumed during the experiment (Table 6) for all the samples varies from 2.0 to 2.8 mol H_2 per mol SnO_2 . The amount of hydrogen consumed during SnO_2 reduction for SnO_2 and SnSi13 samples (temperature range 400–900 °C) is $n = 2.1$ – 2.3 mol H_2 per 1 mol SnO_2 (Table 6), which is close to the theoretical value $n = 2$, corresponding to the reduction of tin dioxide to the metal tin (reaction (4)). An increase in the silicon content leads to a significant reduction in the amount of hydrogen consumed in this temperature range ($n = 1.5$ mol H_2 per 1 mol SnO_2 for SnSi 19 nanocomposite). This may be due to the fact that some Sn cations bonded to SiO_4 groups cannot be completely reduced to Sn^0 under experimental conditions. Compared with the nanocrystalline SnO_2 , in the case of reduction of nanocomposites, an increase in the amount of hydrogen consumed in the low-temperature range (25–400 °C) is observed (Table 6). This is due to an increase in the quantity of surface oxygen-containing species (chemisorbed oxygen and hydroxyl groups), caused by a reduced SnO_2 crystallite size and increased specific surface area of the nanocomposites compared with unmodified SnO_2 .

Table 6. The results of the thermo-programmed reduction with hydrogen (TPR-H₂) experiments.

Sample	Hydrogen Consumption, mol H ₂ per 1 mol SnO ₂		
	Total	at 25–400 °C	at 400–900 °C
SnO ₂	2.2 ± 0.3	0.1 ± 0.03	2.1 ± 0.3
SnSi 13	2.8 ± 0.3	0.5 ± 0.1	2.3 ± 0.3
SnSi 19	2.0 ± 0.2	0.5 ± 0.1	1.5 ± 0.2

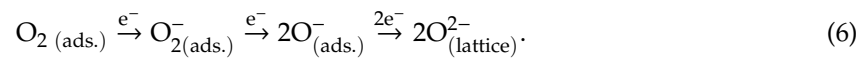
The obtained samples were studied by EPR spectroscopy to assess the effect of SiO₂ on the concentration of paramagnetic centers in tin dioxide. In the spectra obtained, the EPR signal has a complex shape and is a superposition of several lines. As the analysis showed, the spectrum consists of two EPR signals, characterized by the following values of g-factors: (I) $g_1 = 2.027$, $g_2 = 2.008$, $g_3 = 2.003$ in the magnetic field range $\Delta H = 3350\text{--}3440$ G and (II) $g_1 = 1.9989$, $g_2 = 1.9981$ in the magnetic field range $\Delta H = 3440\text{--}3480$ G (Figure 7a,b). According to the literature, the first of the detected EPR signals, characterized by orthorhombic symmetry, can be attributed to the oxygen anion radicals O₂^{•−} [21]. The second EPR signal, characterized by a symmetry close to axial, belongs to the Sn³⁺ paramagnetic centers [22,23]. Perhaps the presence of Sn³⁺ centers is due to the charge transfer from hydroxyl groups to Sn⁴⁺ ions. The calculated concentrations of paramagnetic centers Ns(Sn³⁺) and Ns(O₂^{•−}) are given in Table 7. The obtained values were assigned to the SnO₂ mass fraction in SnO₂/SiO₂ nanocomposites. With an increase in the SiO₂ content, a non-monotonic increase in the number of O₂^{•−} and Sn³⁺ centers is observed.

**Figure 7.** (a) Electron-paramagnetic resonance (EPR) spectra of SnO₂ samples and SnSi 13, SnSi19 composites; (b) EPR spectrum of the SnSi19 sample in a narrow magnetic field range.**Table 7.** Concentration of paramagnetic centers in SnO₂ and SnO₂/SiO₂ nanocomposites.

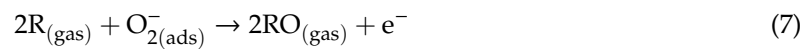
Sample	Ns(O ₂ ^{•−}), g ^{−1} SnO ₂	Ns(Sn ³⁺), g ^{−1} SnO ₂
SnO ₂	3.0×10^{13}	1.3×10^{14}
SnSi 13	9.0×10^{13}	8.8×10^{14}
SnSi 19	1.2×10^{14}	5.8×10^{14}

The set of the obtained results allows us to conclude that the introduction of silicon dioxide during hydrothermal treatment of amorphous xerogel SnO₂·xH₂O and subsequent high-temperature annealing leads to the significant increase in the amount of oxygen-containing surface species, namely chemisorbed oxygen and hydroxyl groups, as well as an increase in the number of paramagnetic centers Sn³⁺, in which tin is in a low oxidation state.

Chemisorption of oxygen occurs on the surface of semiconductor materials with electron capture, thereby affecting the conductivity of the semiconductor:



The ionized forms of chemisorbed oxygen are the main active groups on the surface of SnO₂, interacting with the target reducing gas. Surface reactions leading to the formation of sensor response, in general, can be written as:



where R is a reducing gas molecule and RO is the product of oxidation of R by chemisorbed oxygen. The predominant form of chemisorbed oxygen on the SnO₂ surface is determined by the measurement temperature, the size of the SnO₂ crystallites, and the presence of modifiers on their surface [6,24,25]. To estimate the predominant form of chemisorbed oxygen on the surface of SnO₂ and SnO₂/SiO₂ nanocomposites, the *in situ* measurements of electrical conductivity, depending on the oxygen partial pressure in the gas phase, were carried out. As the partial pressure of O₂ in the gas phase increases, the conductivity of all samples decreases (Figure 8a), which is typical for *n*-type semiconductor oxides. The conductivity is reduced by the reaction occurring on the surface of the samples during oxygen chemisorption [24,26]:



where O₂ gas is an oxygen molecule in the ambient atmosphere, O^{α-}_{β(ads.)} is a chemisorbed oxygen species with: α = 1 for singly ionized forms, α = 2 for doubly ionized forms, β = 1 for atomic forms, and β = 2 for molecular forms. According to the mass action law, in the steady state, the concentration of electrons capable of reaching the surface (n_s) is determined by the partial pressure of gas p(O₂) and the type of chemisorbate (parameters α, β):

$$n_s^\alpha = k_{\text{des.}}/k_{\text{ads.}} \cdot \theta p(\text{O}_2)^{-\beta/2} \quad (10)$$

where k_{ads} and k_{des} are adsorption and desorption constants, respectively, and θ is the part of filled adsorption sites. For a porous nanocrystalline layer, the electrical conductivity (G) linearly depends on p(O₂) in logarithmic coordinates:

$$\lg(G) - \lg\left(1 - \frac{G}{G_0}\right) = \text{const} - m \cdot \lg(p_{\text{O}_2}) \quad (11)$$

where G is conductivity in the presence of oxygen and G₀ is conductivity in an inert atmosphere (argon) [24]. The parameter m = β/2α corresponds to the form of chemisorbed oxygen. Depending on temperature and grain size, the predominant form of chemisorbed oxygen on the surface of *n*-type semiconductor oxides can be O₂⁻ (m = 1), O⁻ (m = 0.5) or O²⁻ (m = 0.25) [24,26].

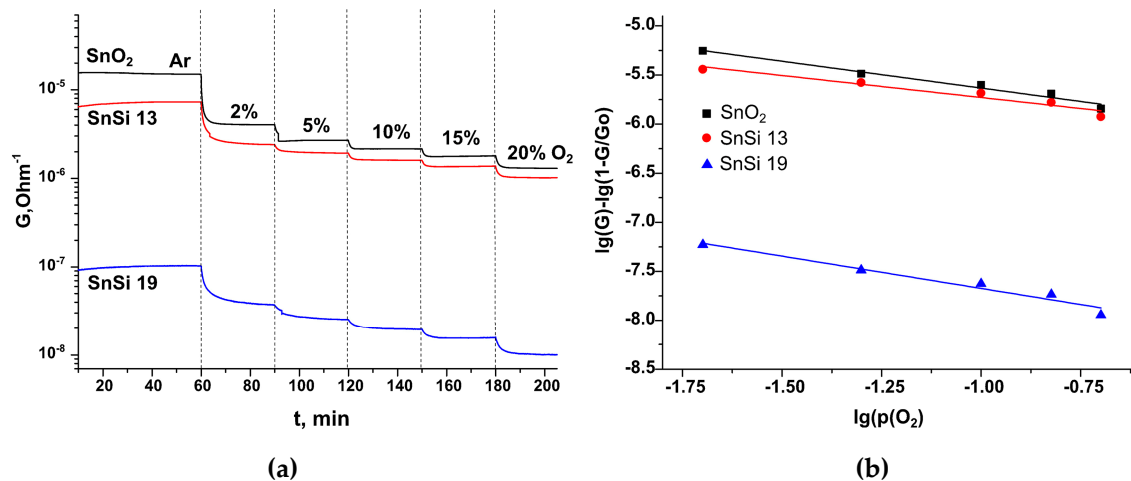


Figure 8. (a) Dependencies of the conductivity of samples on the O_2 partial pressure f at $400\text{ }^\circ\text{C}$; (b) Dependencies $\lg(G) - \lg(1 - \frac{G}{G_0})$ vs. $\lg(p_{O_2})$ for SnO_2 , $SnSi\ 13$, and $SnSi\ 19$ samples.

Based on the data obtained, the dependencies of $\lg(G) - \lg(1 - \frac{G}{G_0})$ vs. $\lg(p_{O_2})$ were plotted (Figure 8b). Linearization in these coordinates is valid for nanoparticles smaller than 25 nm [24–26]. The values of the coefficient m , corresponding to the predominant type of chemisorbed oxygen, were calculated from the slope of the obtained dependences. The results are presented in Table 8.

Table 8. Coefficient m (Equation (11)) obtained from $\lg(G) - \lg(1 - \frac{G}{G_0})$ vs. $\lg(p_{O_2})$ dependencies.

Sample	Coefficient m		
	$400\text{ }^\circ\text{C}$	$300\text{ }^\circ\text{C}$	$200\text{ }^\circ\text{C}$
SnO_2	0.55 ± 0.05	0.51 ± 0.08	-
$SnSi\ 13$	0.46 ± 0.06	0.70 ± 0.20	0.60 ± 0.20
$SnSi\ 19$	0.67 ± 0.08	0.60 ± 0.10	0.80 ± 0.30

The error values of the coefficients m for the measurements effectuated at 200 and $300\text{ }^\circ\text{C}$ are too large for accurate identification of the predominant form of chemisorbed oxygen. However, by analyzing the data presented in Table 8, the following trends can be identified: (i) At $400\text{ }^\circ\text{C}$, the values of the coefficient m for SnO_2 and $SnSi\ 13$ coincide within the error and correspond to the predominant form of chemisorbed oxygen O^- . For the $SnSi\ 19$ nanocomposite, the value of the coefficient m corresponds to the simultaneous presence of atomic O^- and molecular O_2^- forms of chemisorbed oxygen; (ii) with a decrease in the measurements temperature, an increase in the coefficient m is observed, which corresponds with an increase in the proportion of chemisorbed oxygen in the O_2^- form; (iii) in general, an increase in the silicon content in nanocomposites leads to an increase in the contribution of molecular ions O_2^- , which is consistent with the data obtained by EPR spectroscopy.

A change in the type and concentration of charged active centers affects the electrical conductivity of nanocrystalline semiconductors. As it was demonstrated by impedance spectroscopy [27], the transport properties of nanocrystalline SnO_2 are dominated by hopping conduction through disordered crystallite boundaries. The obtained temperature dependences of conductivity are well straightened in Mott coordinates (Figure 9).

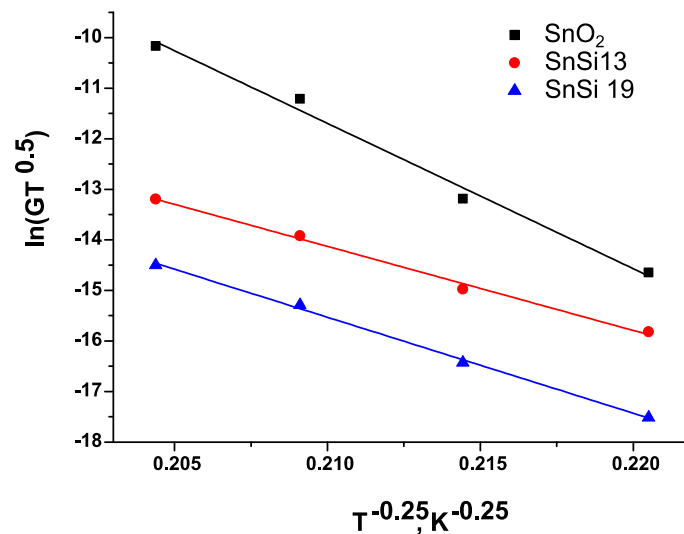


Figure 9. The thermal dependences of the conductivity SnO₂, SnSi 13, and SnSi 19 samples in Mott coordinates in the temperature range 400–150 °C.

In this model, the expression for conductivity (G) is written as:

$$G = \frac{G_M}{T^{0.5}} \exp\left[-\left(\frac{T_M}{T}\right)^{0.25}\right], \quad (12)$$

where G_M and T_M are characteristic Mott parameters. The coefficient G_M is the conductivity of the film at an inverse temperature of $1/T$, tending to 0. As a result of the logarithm of Equation (12), we obtain:

$$\ln(G \cdot T^{0.5}) = \ln(G_M) - \left(\frac{T_M}{T}\right)^{0.25}. \quad (13)$$

when linearizing the dependence $\ln(G \cdot T^{0.5}) = f(T^{-0.25})$, the T_M value can be calculated from the slope of the straight line. The parameter T_M is inversely related to the density of localized states near the Fermi level $N(E_F)$:

$$T_M = \frac{16\alpha^3}{k_B N(E_F)}, \quad (14)$$

where α is the value describing the degree of spatial localization of the wave function and k_B is the Boltzmann constant. Knowing the of $N(E_F)$ value, one can calculate the hopping distance R_{hop} :

$$R_{\text{hop}} = \left(\frac{9}{8\pi\alpha k_B T N(E_F)}\right)^{0.25} \quad (15)$$

and hopping energy W_{hop} :

$$W_{\text{hop}} = \frac{3}{4\pi R^3 N(E_F)}. \quad (16)$$

Table 9 shows the parameters characterizing the conductivity of the samples under study in the framework of the Mott model. In the calculations, the value of α was taken equal to 1.24 nm^{-1} [28].

Table 9. Parameters calculated within the Mott conductivity model: T_M , $N(E_F)$, R_{hop} , and W_{hop} for samples SnO₂, SnSi 13, and SnSi 19.

Sample.	T_M , 10 ⁸ K	$N(E_F)$, 10 ¹⁷ eV ⁻¹ ·cm ⁻³	R_{hop} , nm		W_{hop} , eV	
			25 °C	200 °C	25 °C	200 °C
SnO ₂	68.9	0.52	21	19	0.46	0.67
SnSi 13	7.8	4.7	12	11	0.27	0.39
SnSi 19	13.5	2.6	14	13	0.31	0.43

The data obtained satisfies the criteria of applicability of the Mott model. For all the cases under consideration, the conditions $W > kT$ and $\alpha R \gg 1$ are satisfied [28]. The obtained values of the Mott parameters indicate a high degree of disorder of the studied systems. Linearization of experimental data in Mott coordinates (Figure 9) indicates that the charge transfer in nanocrystalline SnO₂ and nanocomposites is carried out by the hopping conductivity of electrons through localized states lying near the Fermi level. The addition of SiO₂ leads to a decrease in the slope of the linear dependences $\ln(G \cdot T^{0.5}) = f(T^{-0.25})$: $T_M(\text{SnO}_2) > T_M(\text{SnSi 19}) > T_M(\text{SnSi 13})$, which indicates an increase in the density of unfilled local states and is consistent with data obtained by EPR spectroscopy. Compared to nanocrystalline SnO₂, an increase in the concentration of Sn³⁺ in SnO₂/SiO₂ nanocomposites also causes a decrease in the hopping distance R_{hop} and hopping energy W_{hop} . This should lead to an increase in the mobility of charge carriers in nanocomposites. The observed decrease in the electrical conductivity of materials with an increase in the SiO₂ concentration in nanocomposites is apparently due to a decrease in the concentration of charge carriers because of their localization on chemisorbed oxygen (reaction (9)), which amount increases in a row: SnO₂ < SnSi 13 < SnSi 19 (Table 7).

4. Conclusions

Nanocomposites SnO₂/SiO₂ were synthesized via a hydrothermal route. The introduction of silicon dioxide at the stage of hydrothermal treatment of β -stannic acid allows obtaining semiconductor materials with a high specific surface area resistant to sintering at 600 °C. The modification of SnO₂ nanocrystalline matrix with amorphous SiO₂ results in the increase in the concentration of paramagnetic centers Sn³⁺, surface hydroxyl groups and chemisorbed oxygen and leads to a decrease in the negative charge on chemisorbed oxygen species. The conductivity of nanocomposites is described in the framework of the Mott hopping conduction model. Compared to nanocrystalline SnO₂, an increase in the concentration of Sn³⁺ in SnO₂/SiO₂ nanocomposites causes a decrease in the hopping distance and hopping energy, which should lead to an increase in the mobility of charge carriers in the nanocomposites.

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